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PATENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Confirmation No.: 4861

Yasuhiro KOIZUMI et al

Art Unit: 2877

S. N. 09/920,450

Examiner: J. D. Valentin

Filed: August 1, 2001

For: DEFECT INSPECTION APPARATUS FOR PHASE SHIFT MASK

AMENDMENT ACCOMPANYING RCE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Prior to examination of this RCE application, please enter
the following amendments.

Claims begin on page 2 of this document.

Remarks begin on page 5 of this document.